

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Chisin Chiang	09/13/2010
Antony Nguyen	09/13/2010
Jr-Yi Shen	09/13/2010
RECEIVING PARTY DATA	
Name:	Hitachi Global Storage Technologies, Netherlands, B.V.
Street Address:	Locatellikade 1, Parnassustoren
City:	Amsterdam
State/Country:	NETHERLANDS
Postal Code:	1076 AZ
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	12887461
CORRESPONDENCE DATA	
Fax Number:	(831)722-2350
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	4083770500
Email:	bdinapoli@wagnerblecher.com
Correspondent Name:	Hitachi C/O Wagner Blecher LLP
Address Line 1:	123 Westridge Dr
Address Line 4:	Watsonville, CALIFORNIA 95076
ATTORNEY DOCKET NUMBER:	HSJ920100020US1
NAME OF SUBMITTER:	Amber Grewer
Total Attachments: 1 source=HJP920100020US1_Assignment#page1.tif	

CH \$40.00 12887461

501401079

PATENT
REEL: 025607 FRAME: 0522

ASSIGNMENT FOR PATENT APPLICATION

Whereas, I/we the undersigned inventor(s) have invented certain improvements as set forth in the patent application entitled:

RETAINING A SPOILER IN A HARD DISK DRIVE

Whereas, Hitachi Global Storage Technologies Netherlands B.V., having a place of business at Locatellikade 1, Parnassustoren, 1076 AZ Amsterdam, The Netherlands (hereinafter referred to as "HITACHI"), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefore;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I/we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed on the date(s) indicated beside my (our) signature(s).

- 1) Signature: Kimihiro Sudo Date: Dec. 15, 2010
Typed Name: Kimihiko SUDO
- 2) Signature: Hiromitsu Masuda Date: Dec 15, 2010
Typed Name: Hiromitsu Masuda
- 3) Signature: Kouki Uefune Date: Dec 15, 2010
Typed Name: Kouki UEFUNE
- 4) Signature: Yoshiyuki Hirano Date: Dec 16, 2010
Typed Name: Yoshiyuki Hirano